

	Ref #	Type	Hits	Search Text	DBs
50	S140	BRS	623746	actuator micro\$1valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
51	S141	BRS	4452472	fluid liquid	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
52	S142	BRS	1495	multi\$1stable	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
53	S143	BRS	2839019	partial intermediate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
54	S144	BRS	1	S140 same S141 same S142	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
55	S145	BRS	0	S143 same S144	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
56	S146	BRS	4481	S140 same S141 same S143	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
57	S147	BRS	120122	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mem or microactuator or micro\$1switch)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB

	Ref #	Type	Hits	Search Text	DBs
58	S148	BRS	230	S146 and S147	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
59	S149	BRS	1202	335/78.ccls. 200/181.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
60	S150	BRS	6240	microvalve microactuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
61	S151	BRS	2873711	substrate wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
62	S152	BRS	3319974	ic ("integrated circuit") transistor controller	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
63	S155	BRS	624841	microvalve microactuator actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
64	S156	BRS	13	IMEMS.ab.	US-PGPUB; USPAT; USOCR
65	S157	BRS	6240	microvalve microactuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB

	Ref #	Type	Hits	Search Text	DBs
66	S158	BRS	2873711	substrate wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
67	S159	BRS	3319974	ic ("integrated circuit") transistor controller	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
68	S160	BRS	200	S157 same S159 same S158	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
69	S161	BRS	624841	microvalve microactuator actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
70	S162	BRS	6213671	ic ("intergrated circuit") circuit transistor controller	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
71	S163	BRS	2873711	substrate wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
72	S164	BRS	8665	S161 same S162 same S163	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
73	S165	IS&R	10193	(251/129.01-129.19).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB

	Ref #	Type	Hits	Search Text	DBs
74	S166	BRS	623746	actuator micro\$1valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
75	S167	BRS	4452472	fluid liquid	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
76	S168	BRS	1495	multi\$1stable	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
77	S169	BRS	623746	actuator micro\$1valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
78	S170	BRS	1	S169 same S167 same S168	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
79	S171	BRS	1293	335/78.ccls. 200/181.ccls. 251/129.01-129.19.ccls.	US-PGPUB
80	S172	BRS	47320	(microelectromechanical or micro-electromechanical or micro-electro-mechanical or mem or microactuator or micro\$1switch or micro\$1valve or actuator).clm.	US-PGPUB
81	S173	BRS	336720	(ic ("intergrated circuit") circuit transistor controller).clm.	US-PGPUB
82	S174	BRS	13537	S172 and S173	US-PGPUB
83	S175	BRS	221071	(substrate wafer).clm.	US-PGPUB
84	S176	BRS	2158	S174 and S175	US-PGPUB
85	S177	BRS	43	S171 and S176	US-PGPUB

86	S178	BRS	98608	(multi\$1stable partial intermediate).clm.	US-PGPUB
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	Ref #	Type	Hits	Search Text	DBs
87	S179	BRS	222970	(fluid liquid).clm.	US-PGPUB
88	S180	BRS	15520	S178 and S179	US-PGPUB
89	S181	BRS	0	S177 and S180	US-PGPUB
90	S182	BRS	948	S172 and S180	US-PGPUB
91	S183	BRS	14	S171 and S182	US-PGPUB
92	S184	BRS	343975	(membrane layer beam).clm.	US-PGPUB
93	S185	BRS	4867	S178 and S179 and S184	US-PGPUB
94	S186	BRS	205	S172 and S185	US-PGPUB